

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 293375US26PCT		SERIAL NO. 10/585,732	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Toshio HASEGAWA			
		FILING DATE		GROUP		July 12, 2006	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
AA							
AB							
AC							
AD							
AE							
AF							
AG							
AH							
AI							
AJ							
AK							
AL							
AM							
AN							
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
AO							
AP							
AQ							
AR							
AS							
AT							
AU							
AV							
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
AW	Hirotaka HAMAMURA, et al., "TiN Films Prepared by Flow Modulation Chemical Vapor Deposition Using TiCl <sub>4</sub> and NH <sub>3</sub> ", Japanese Journal of Applied Physics, Vol. 40, No. 3A, Part 1, XP001078015, March 1, 2003, pages 1517-1521						
AX							
AY							
AZ					<input type="checkbox"/> Additional References sheet(s) attached		
Examiner		/Khiem Nguyen/				Date Considered 11/20/2009	
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KN/